

U.S. Department of Commerce, Patent and Trademark Office		Docket No.	Serial No.
(PTO Form 1449 modified 4/6 24 2001)		APPM/3421.C1/ISM/ COPPER/DV	09/609,347
<b>SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT</b>		Applicant Cheun, et al.	Confirmation No.:
(Use several sheets if necessary)		Filing Date	Group
Examiner Unknown		July 5, 2000	1741

**U.S. Patent Documents**

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
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	A8						
	A9						
	A10						
	A11						

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**Foreign Patent Documents**

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
CSA	B1	93/17448	09-02-1993	WO	H01L	21/20	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>

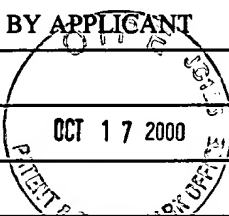
**OTHER ART**

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
CSA	C1	Search Report, prepared for Singapore Appl. No. 00010504, dated May 23, 2001
	C2	
	C3	

Examiner *Erica Smith Hicks*

Date Considered 5-31-01

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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E80t	AA	5,723,028	03/03/1998	Poris	204	231	
	AB	5,718,813	02/17/1998	Drummond et al.	204	192.12	
	AC	5,705,223	01/06/1998	Bunkofske	427	240	
	AD	5,651,865	07/29/1997	Sellers	204	192.13	
	AE	5,625,170	04/29/1997	Poris	177	50	
	AF	5,608,943	03/11/1997	Konishi et al.	15	302	
	AG	5,449,447	09/12/1995	Branders	205	141	
	AH	5,429,733	07/04/1995	Ishida	204	224 R	
	AI	5,415,890	05/16/1995	Kloiber et al.	427	242	
	AJ	5,377,708	01/03/1995	Bergman et al.	134	105	
✓	AK	5,368,711	11/29/1994	Poris	204	193	

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E80t	AL	WO 97/12079	04/03/1997	WIPO	C25D	5/02		X
	AM	JP 06017291	01/25/1994	Japan English Abstract	C25D	7/12		X
	AN	JP 04280993	10/06/1992	Japan English Abstract	C25D	5/18		X
	AO	JP 04131395	05/06/1992	Japan English Abstract	C25D	5/34		X
✓	AP	JP 63118093	05/23/1988	Japan English Abstract	C25D	5/18		X

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E80t	AQ	Lucio Colombo, "Wafer Back Surface Film Removal," Central R&D, SGS-THOMPSON Microelectronics, Agrate, Italy, 6 pages		Year/Month Not Available
E80t	AR	Semitool <sup>o</sup> , Inc., "Metallization & Interconnect," 1998, 4 pages		Month Not Available
E80t	AS	Verteq Online <sup>o</sup> , "Products Overview," 1996-1998, 5 pages		Month Not Available

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E80t	5/31/02

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ERH	BA	5,349,978	09/27/1994	Sago et al.	134	153	
	BB	5,328,589	07/12/1994	Martin	205	296	
	BC	5,316,974	05/31/1994	Crank	437	190	
	BD	5,290,361	03/01/1994	Hayashida et al.	134	2	
	BE	5,259,407	11/09/1993	Tuchida et al.	134	151	
	BF	5,256,274	10/26/1993	Poris	205	123	
	BG	5,252,807	10/12/1993	Chizinsky	219	390	
	BH	5,230,743	07/27/1993	Thompson et al.	134	32	
	BJ	5,224,504	07/06/1993	Thompson et al.	134	155	
	BJ	5,222,310	06/29/1993	Thompson et al.	34	202	
✓	BK	5,162,260	11/10/1992	Leibovitz et al.	437	195	

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		Document Number	Date	Country	Class	Subclass	Yes	No
ERH	BL	JP 58182823	10/25/1983	Japan English Abstract	H01L	21/288		X
	BM							
	BN							
	BO							
	BP							

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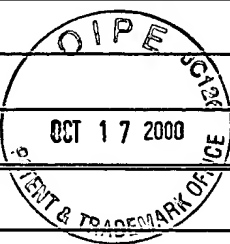
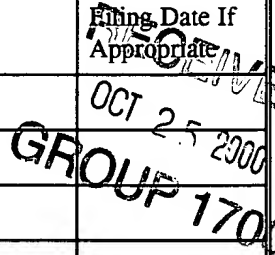
ERH	BQ	Kenneth E. Pitney, "NEY Contact Manual," Electrical Contacts for Low Energy Uses, (1973), 19 pages, <sup>month not available</sup>
ERH	BR	Peter Singer, "Wafer Processing," Semiconductor International, June 1998, 1 page.
ERH	BS	Peter Singer, "Tantalum, Copper and Damascene: The Future of Interconnects," Semiconductor International, June 1998, 6 pages.

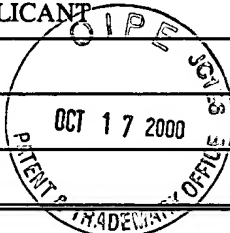
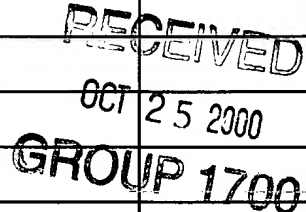
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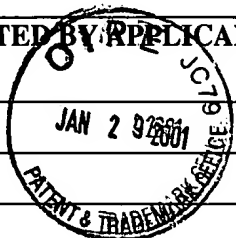
*Glenn Smith* *8/31/02*

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ES	CA	5,155,336	10/13/1992	Gronet et al.	219	411		
	CB	5,100,516	03/31/1992	Nishimura et al.	205	145		
	CC	5,092,975	03/03/1992	Yamamura et al.	204	198		
	CD	5,069,760	12/03/1991	Tsukamoto et al.	205	80		
	CE	5,055,425	10/08/1991	Leibovitz et al.	437	195		
	CF	5,039,381	08/13/1991	Mullarkey	204	47.5		
	CG	4,732,785	03/22/1988	Brewer	427	240		
	CH	4,693,805	09/15/1987	Quazi	204	192.22		
	CI	4,519,846	05/28/1985	Aigo	134	15		
	CJ	4,518,678	05/21/1985	Allen	430	311		
✓	CK	4,510,176	04/09/1985	Cuthbert et al.	427	82		
Foreign Patent Documents								
							Translation	
		Document Number	Date	Country	Class	Subclass	Yes	No
	CL							
	CM							
	CN							
	CO							
	CP							
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ES	CQ	Ragnar Holm, "Electric Contacts Theory and Application," Springer-Verlag New York Inc. 1967, 26 pages. **						
ES	CR	Technologies Corporation, "Two control configurations available" 1998, 6 pages **						
	CS	** = Month Not Available						
Examiner			Date Considered					
Erica Smith			5/31/02					
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ESP	DA	4,489,740	12/25/1984	Rattan et al.	134	140		
	DB	4,435,266	03/06/1984	Johnston	204	276		
	DC	4,428,815	01/31/1984	Powell et al.	204	297 W		
	DD	4,405,416	09/20/1983	Raistrick et al.	204	68		
	DE	4,376,685	03/15/1983	Watson	204	52 R		
	DF	4,336,114	06/22/1982	Mayer et al.	204	52 R		
	DG	4,315,059	02/09/1982	Raistrick et al.	429	112		
	DH	4,113,492	09/12/1978	Sato, et al.	96	67		
	DI	4,110,176	08/29/1978	Creutz, deceased et al.	204	52 R		
	DJ	4,092,176	05/30/1978	Kozai et al.	134	186		
	DK	4,027,686	06/07/1977	Shortes et al.	134	33		
	DL	3,770,598	11/06/1973	Creutz	204	52 R		
	DM	3,727,620	04/17/1973	Orr	134	95		
Foreign Patent Documents								
							Translation	
		Document Number	Date	Country	Class	Subclass	Y es	No
	DN							
	DO							
	DP							
	DQ							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	DR							
	DS							
	DT							
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Edrice Smith				5/31/02				
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(Use several sheets if necessary)		Filing Date 07/05/2000	Group 1741
Examiner			



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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
<i>COA</i>	A1	5,324,684	06/28/1994	Kermani, et al.	437	95	02/25/1992
	A2						
	A3						
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	A11						
	A12						
	A13						

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## Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input type="checkbox"/>

## OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
<i>BA</i>	C1	European Search Report dated December 11, 2000.
	C2	
	C3	

Examiner *Eric Smet* Date Considered *5/31/02*

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